

NV Formation through Repeated Annealing

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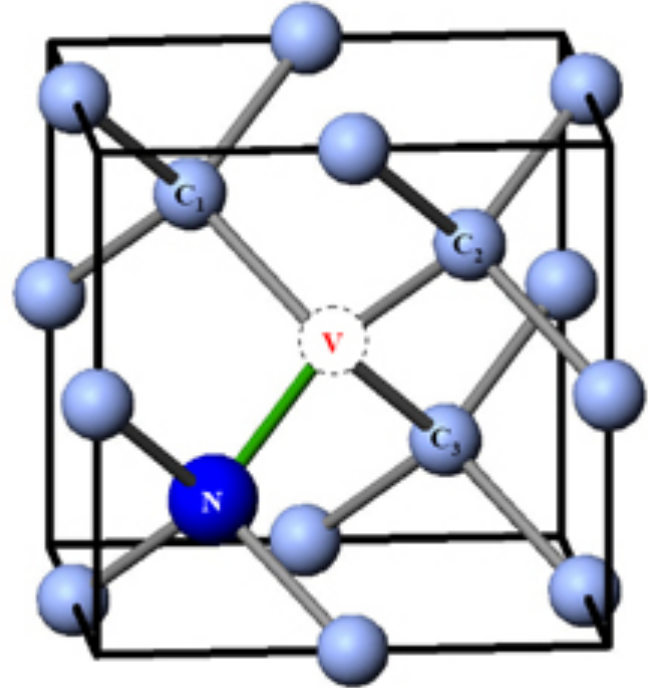
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Nitrogen-Vacancy Center

- Point defect in diamond
- Substitutional nitrogen with adjacent vacancy
- Optically accessible spin states

Applications

- Quantum sensing
- Quantum information



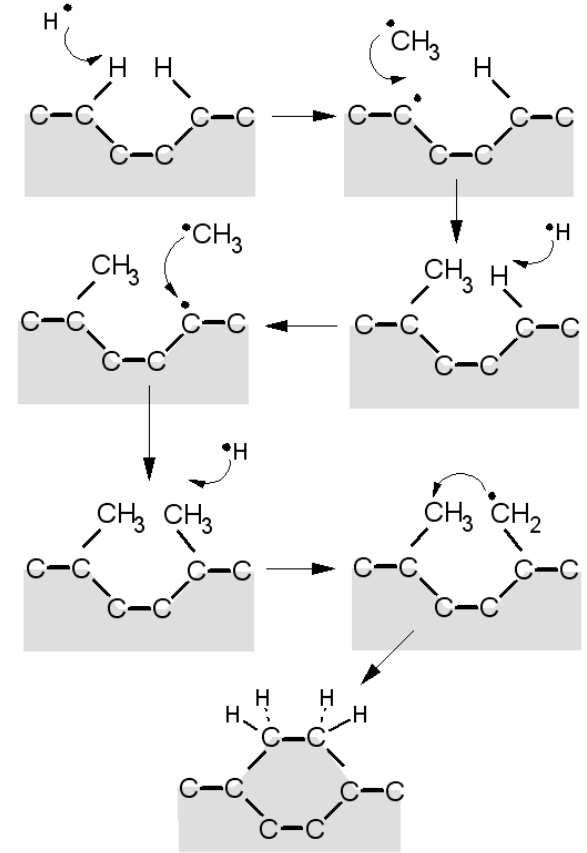
Awschalom Group: Quantum Computing with Defects, University of Chicago

Incorporating nitrogen into diamond

- Grown-in
- Irradiation

Our sample:

- Single crystal diamond
- Grown in substitutional nitrogen
- Chemical vapor deposition (CVD)
- High purity (nitrogen is <0.5 ppb)
- Low vacancy concentration



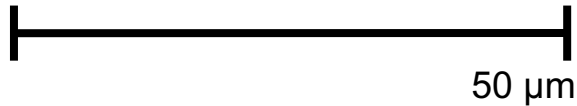
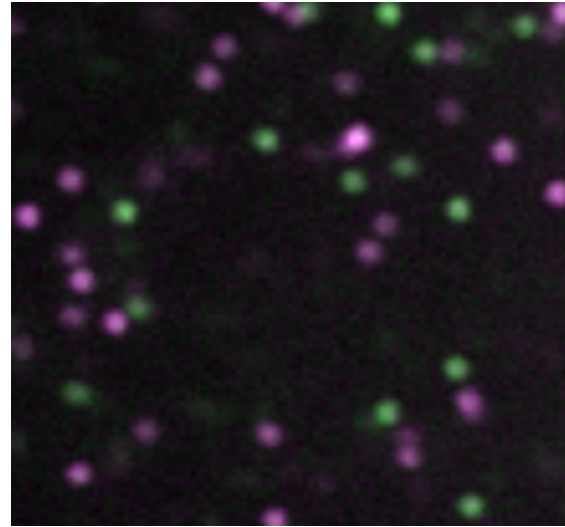
CVD Diamond Group, University of Bristol

Imaging

- Confocal scanning
- Excite NV- with 532 nm green laser
- Collect 637 nm light with SPCM



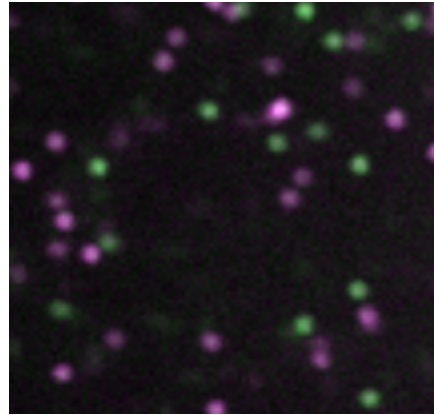
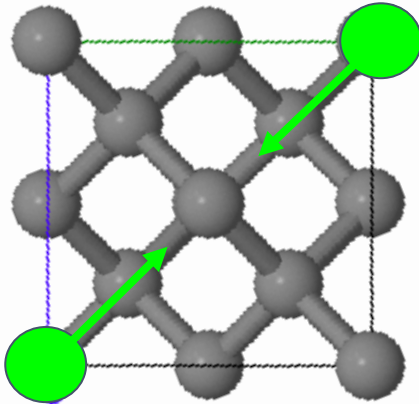
2000x2000x500 μm^3
diamond sample



NV Orientations

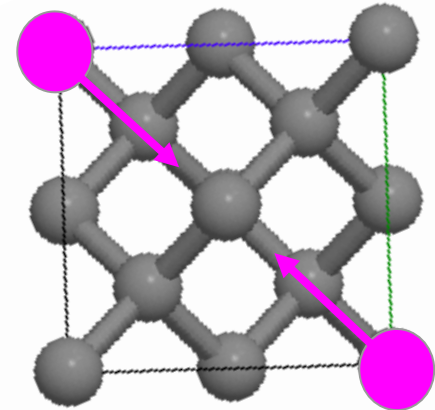
- 8 possible orientations, 2 distinguishable in our setup
- Intensity = dot product of laser polarization axis with NV orientation axis
- 90° between the two orientations

O1 orientation:



50 μm

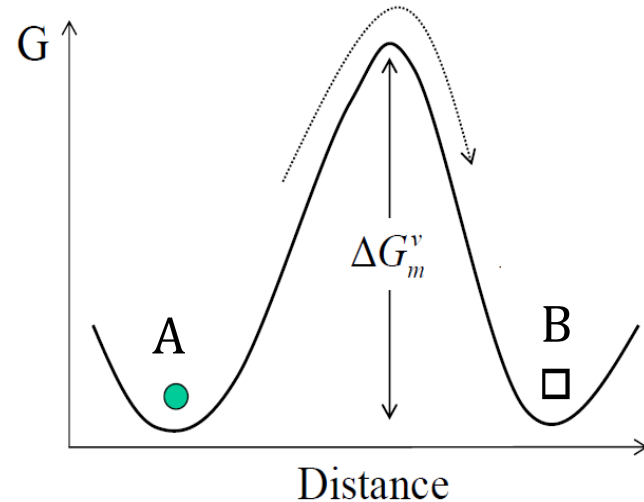
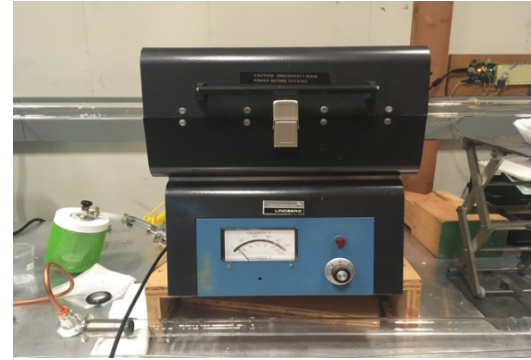
O2 orientation:



Annealing

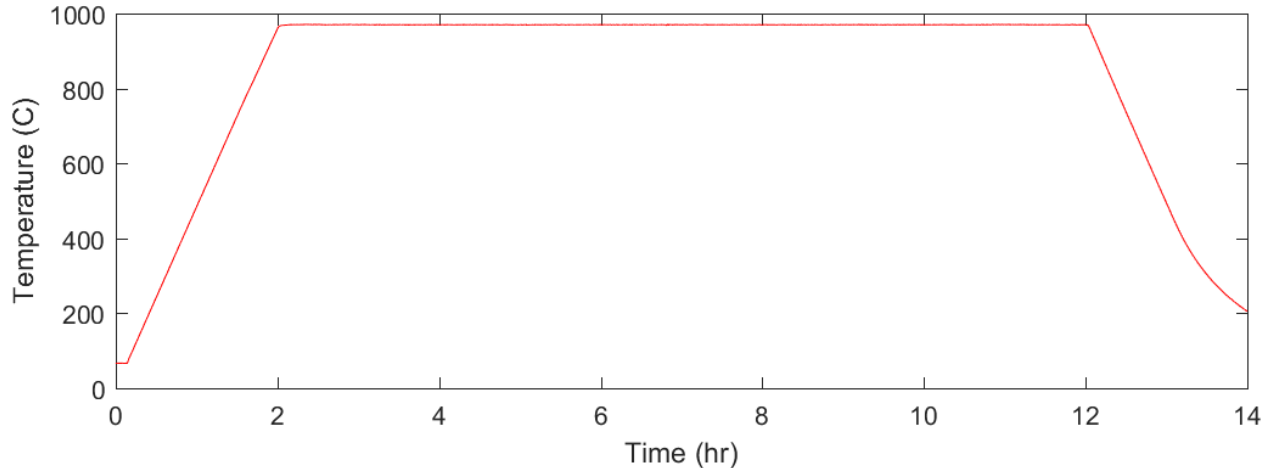
Anneal = heat slowly, hold temp, cool slowly

- Adds energy to the lattice
 - Creates new species
 - Mobilizes species



Possible Benefits of Annealing

- Control orientation of NVs (with strain?)
- Control density of NVs without damaging the lattice
- Increase NV density?



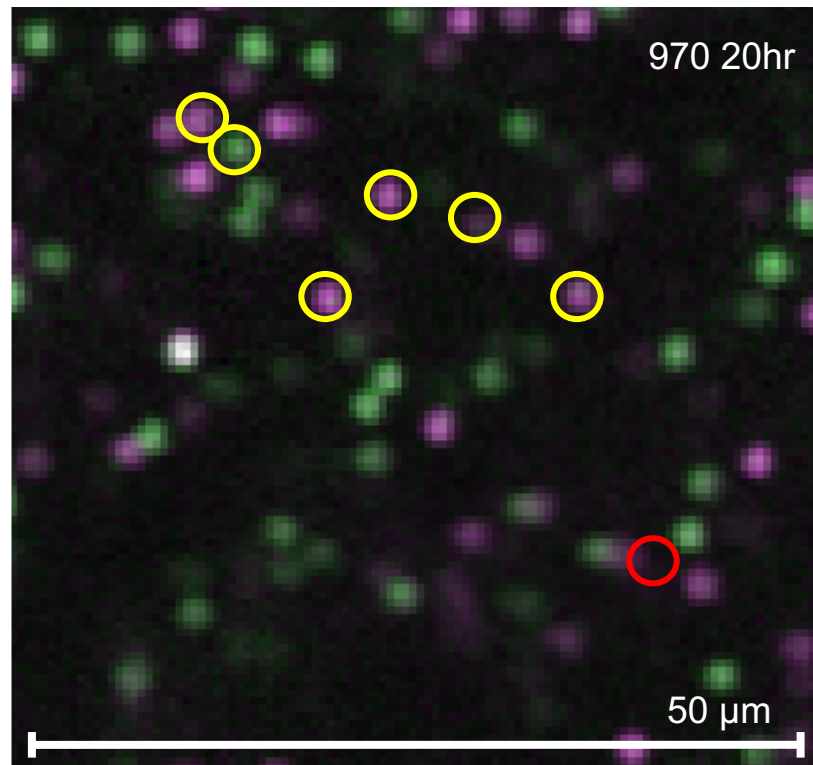
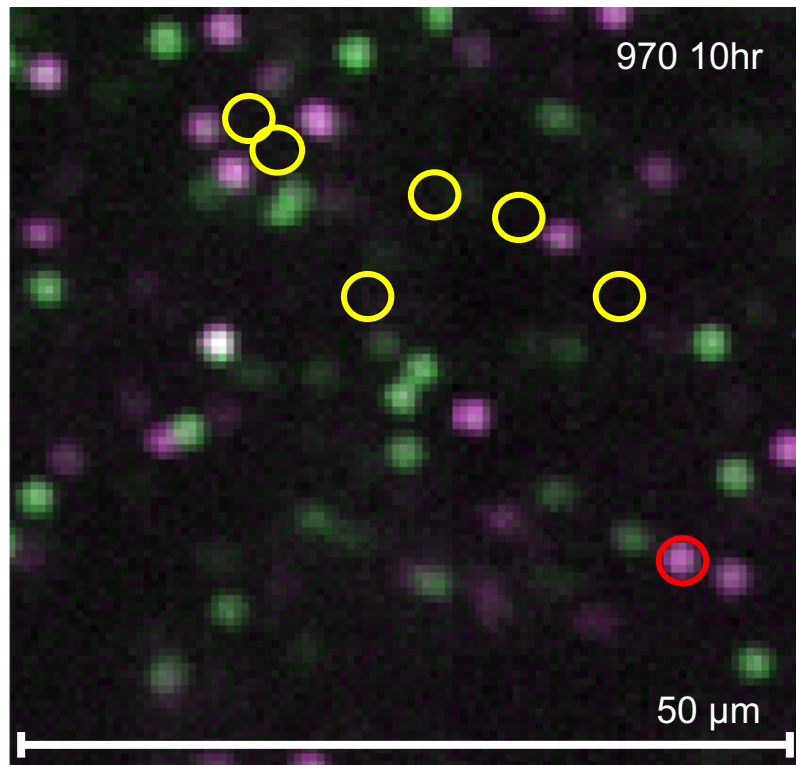
Anneals

Temperature (°C)	Time (hrs)
800	2
800	10
950	10
960	10
960	10
970	2
970	10
970	20
980	2

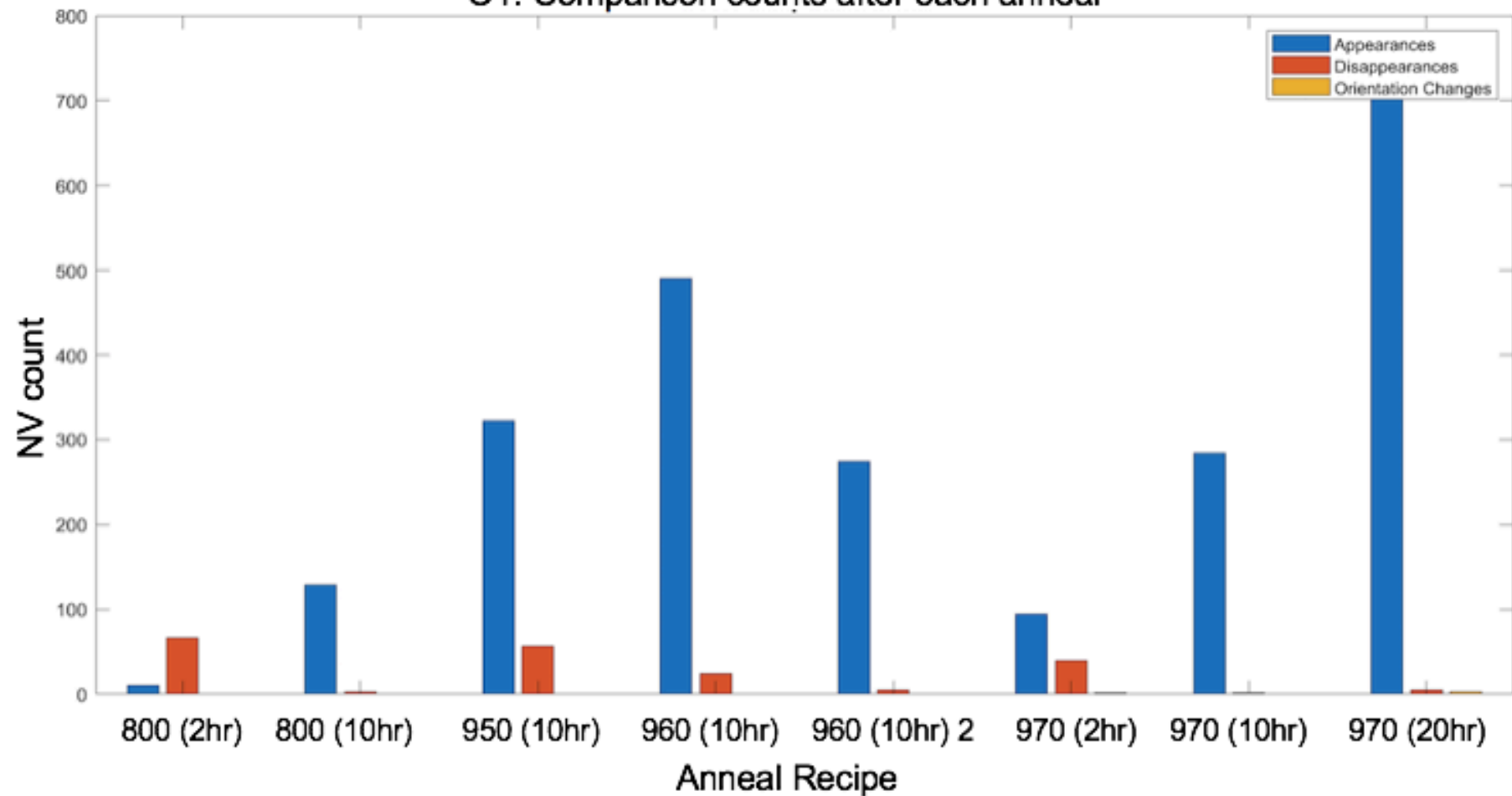
Large Scan Methods

- total area: $350 \mu\text{m}^2$
- scan takes about 18 hours
- 240 μm depth (from top surface)
- 81 $50 \times 50 \mu\text{m}^2$ small piezo scans stitched together (162 total)
- Used a larger stage to move between small scans
- Compared sequential large scans
- Tallied appearances, disappearances, possible reorientations

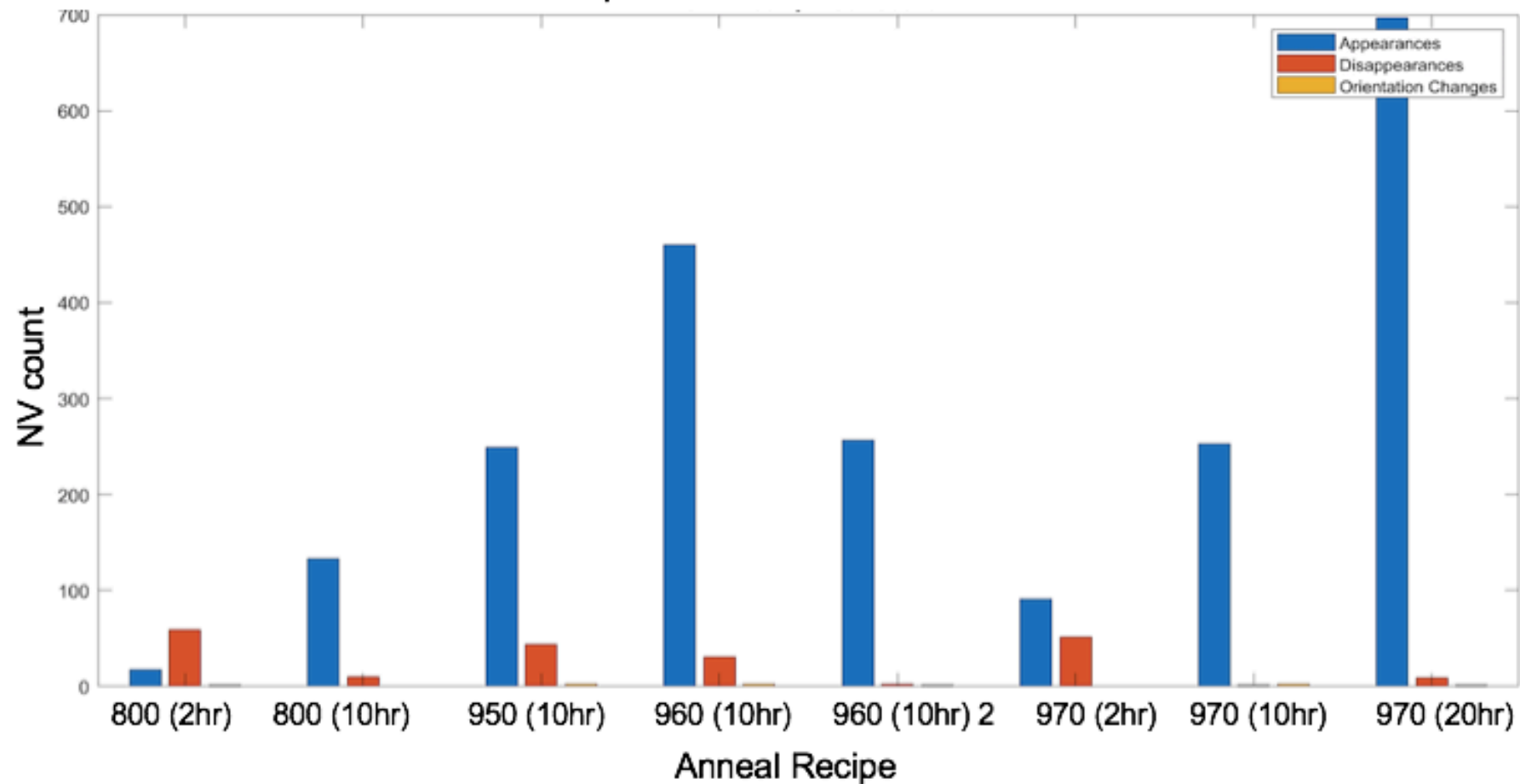
Large Scan Data: Comparisons



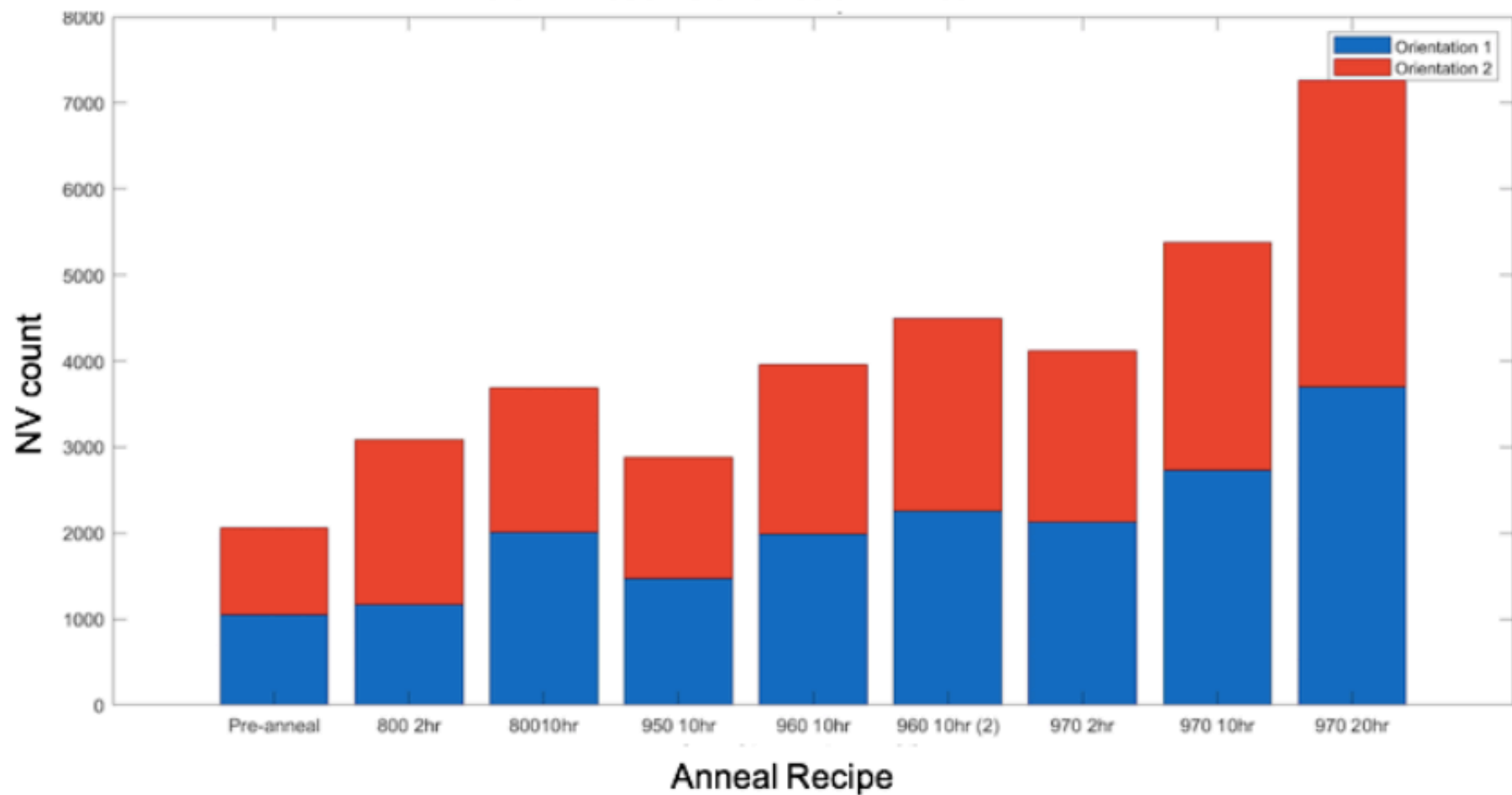
O1: Comparison counts after each anneal



O2: Comparison counts after each anneal



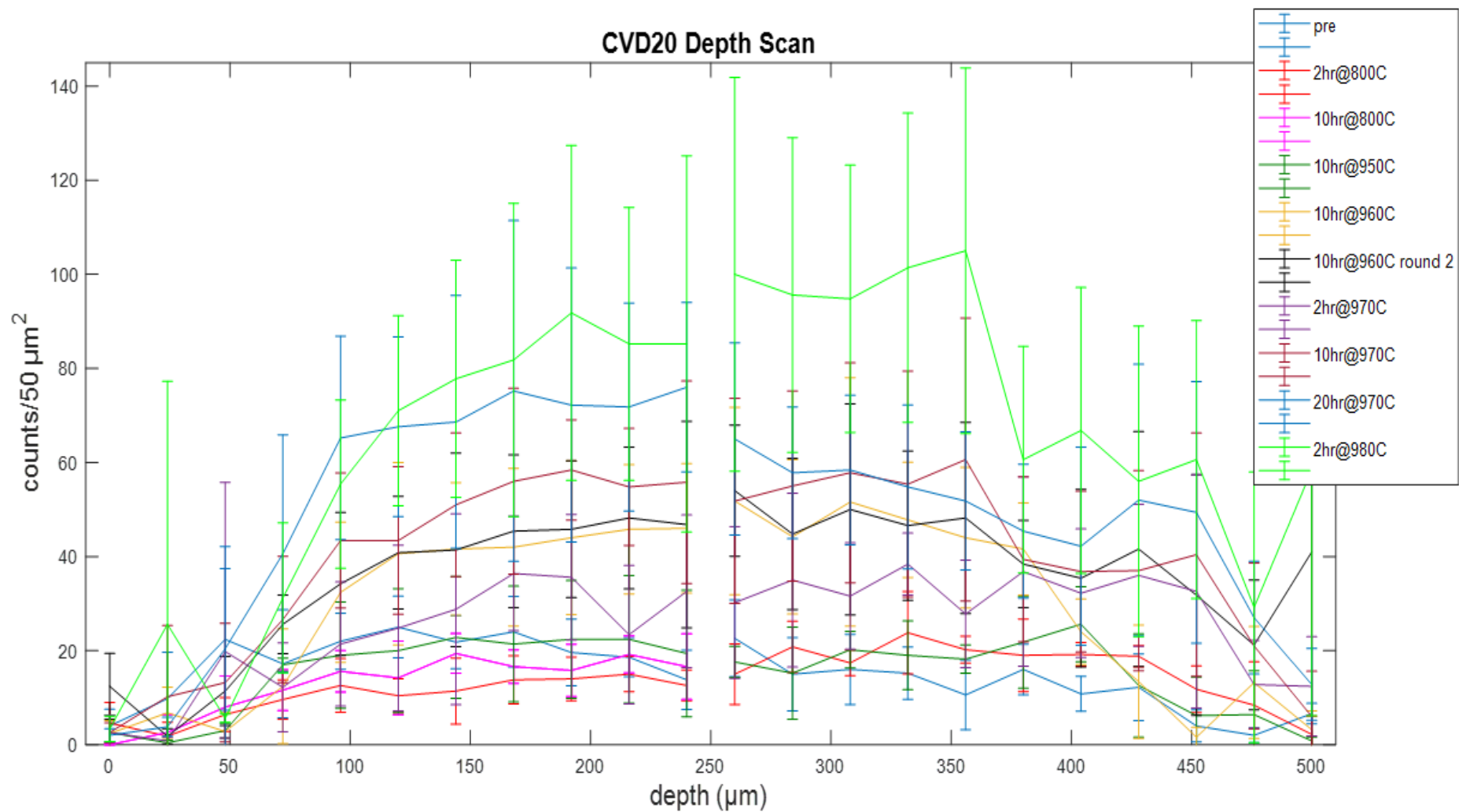
Total NV counts after each Anneal



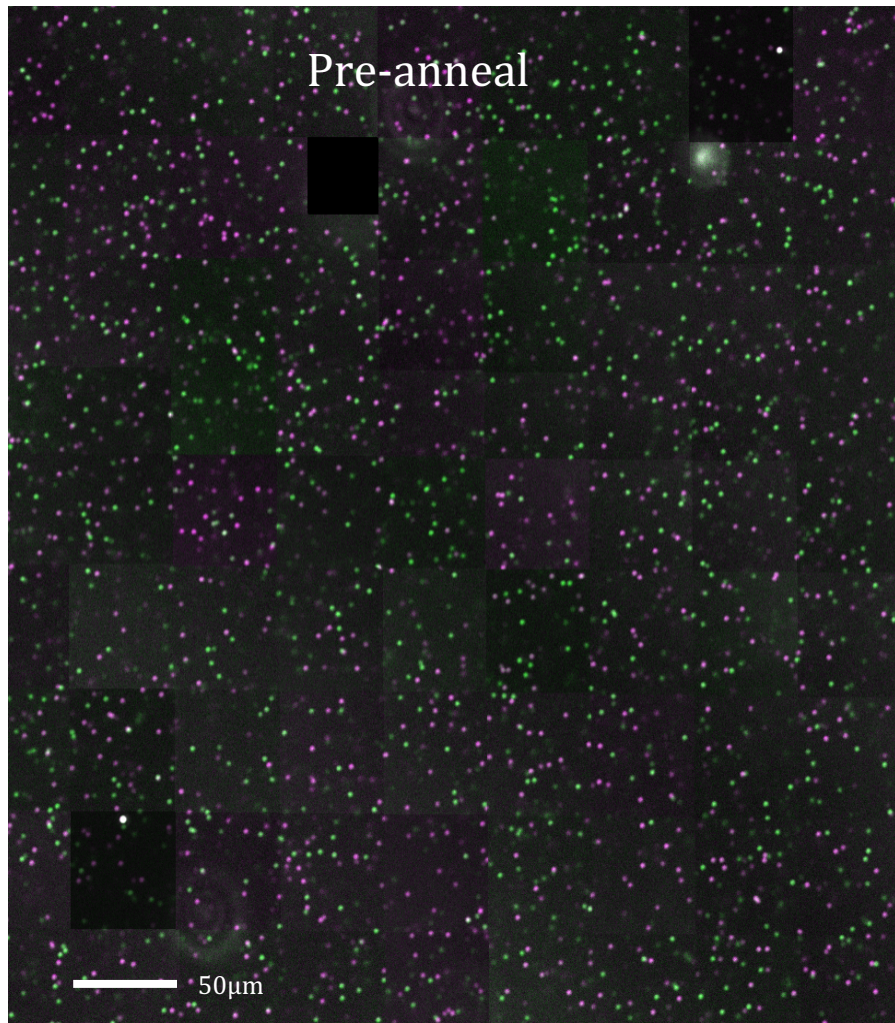
Depth Scan Methods

- Five different $50 \times 50 \mu\text{m}^2$ areas averaged per depth
- 11 depths: from $0 \mu\text{m}$ (surface) to $100 \mu\text{m}$ (max range of objective) every $10 \mu\text{m}$
- Two separate depth scans for both surfaces

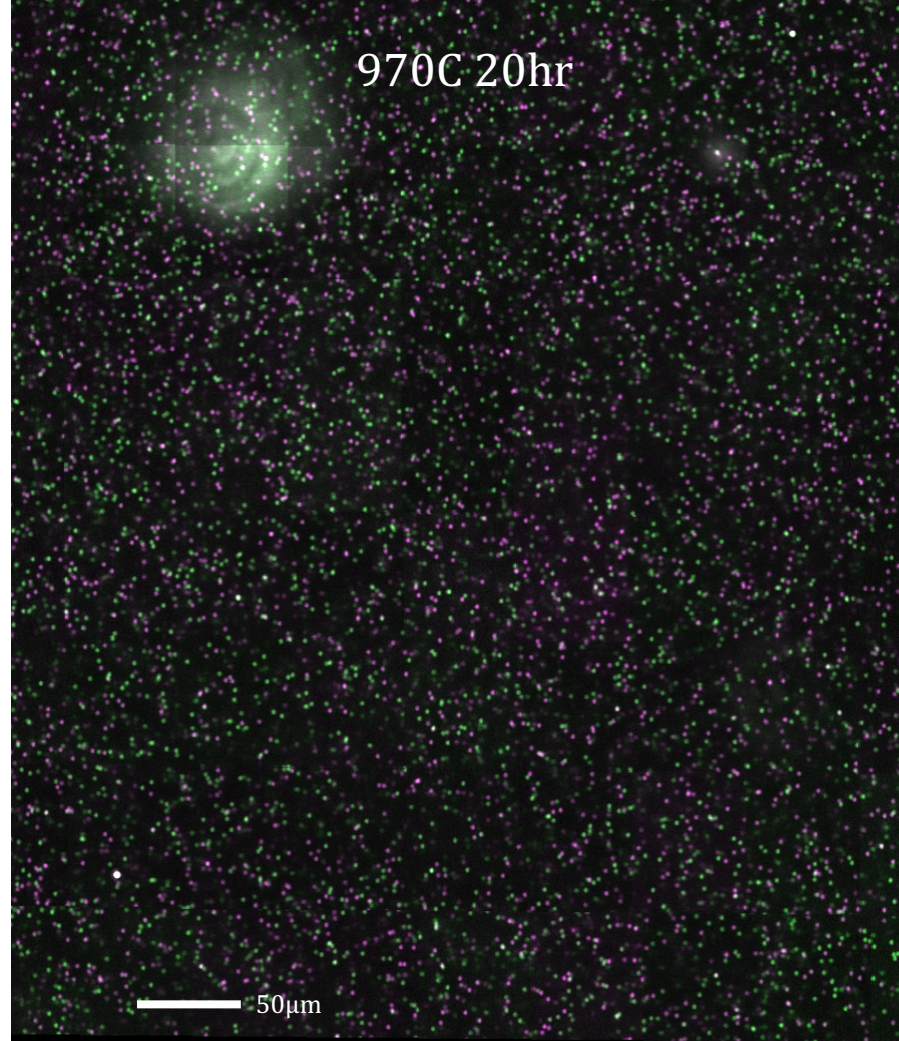
CVD20 Depth Scan



Pre-anneal



970C 20hr



Why we should not see a major increase in NV-

- Relatively low vacancy and nitrogen concentration
 - low probability of finding each other
- Other possible defects stable up to high temperatures
 - NVH (>1600C)
 - Nitrogen aggregates
 - Vacancy aggregates

Theories

- NV0 turning into NV-
 - Via high energy photons (4)
- Presence of some other defect (Nickel, Boron, etc.)

Future Work

- more data: more anneals with more samples
- scan for other defects: NV0, etc.
- Is repeated annealing a viable way to increase NV concentration in diamond?

References

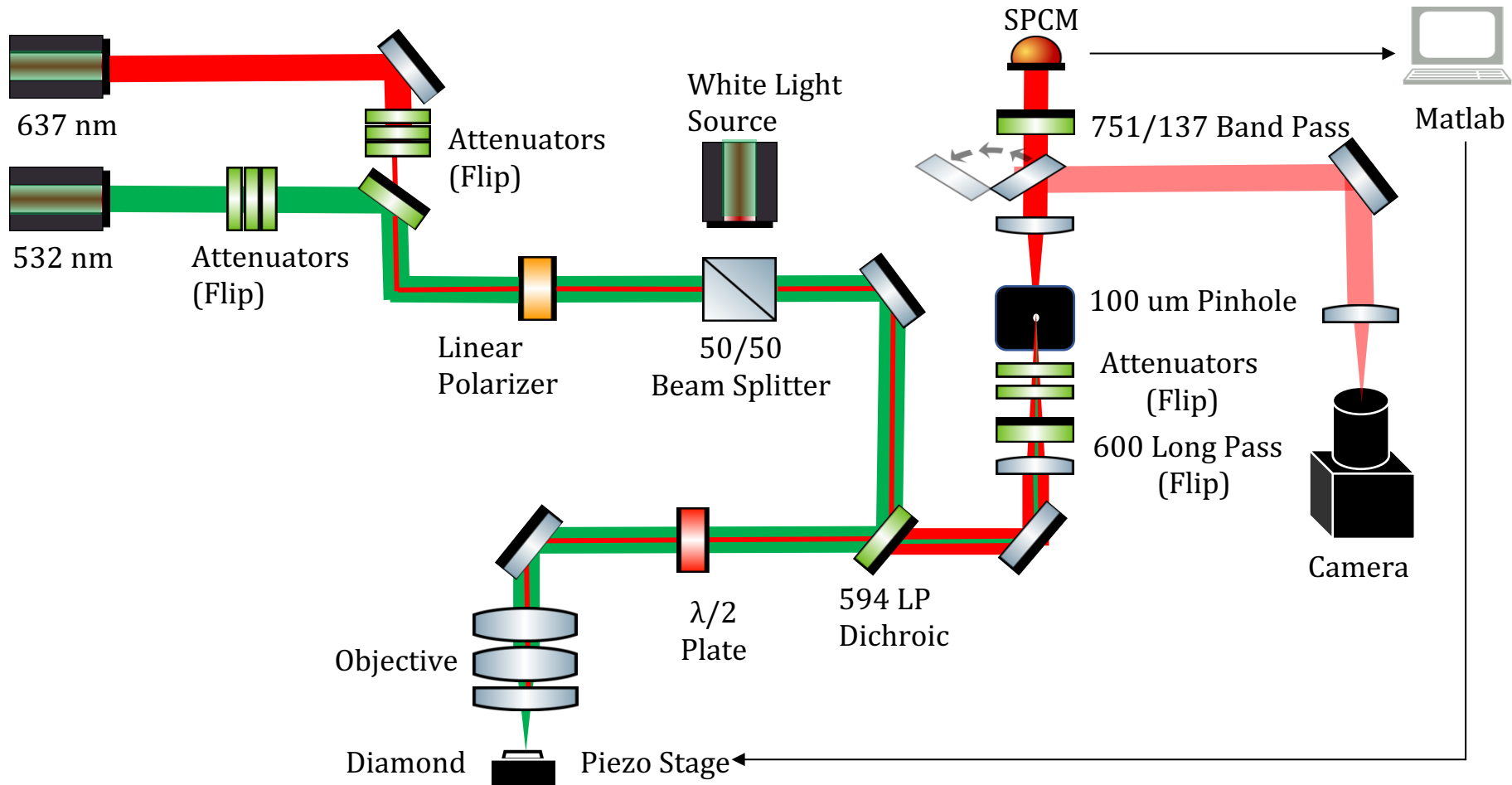
- (1) Deák, Peter, et al. "Formation of NV centers in diamond: A theoretical study based on calculated transitions and migration of nitrogen and vacancy related defects." *Physical Review B* 89.7 (2014): 075203.
- (2) Pinto, H., et al. "On the diffusion of NV defects in diamond." *physica status solidi (a)* 209.9 (2012): 1765-1768.
- (3) Mainwood, Alison. "Nitrogen and nitrogen-vacancy complexes and their formation in diamond." *Physical Review B* 49.12 (1994): 7934.
- (4) Khan, R. U. A., et al. "Colour-causing defects and their related optoelectronic transitions in single crystal CVD diamond." *Journal of Physics: Condensed Matter* 25.27 (2013): 275801.
- (5) Karin, Todd, Scott Dunham, and Kai-Mei Fu. "Alignment of the diamond nitrogen vacancy center by strain engineering." *Applied Physics Letters* 105.5 (2014): 053106.

Processes during Anneal

Temperature (°C)	Process	Energy (eV)	Max Stable Temp (°C)
T > 600	$C_i + V \rightarrow \emptyset$		
T < 800	$N_i + N_s \rightarrow N_2$		
	$N_i + V \rightarrow NV?$		
	N_i mobile		650
	V^0 mobile	+2.3 ± .3	
T > 800	$N_s + V^0 \rightarrow (NV^-) + h$	+5.8	1700
	$N_2 + V^0 \rightarrow N_2V$	+5.65	2200
	$2V \rightarrow V_2$	+4.2	1100
	$N_s + VH \rightarrow NVH$	+2.3	1600

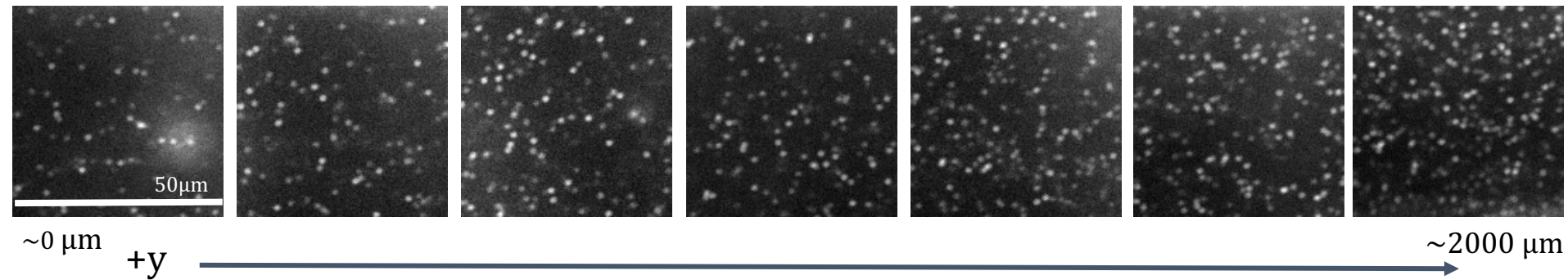
Theories

- NV forming via N + V (vacancy migrating to nitrogen)
 - Unlikely due to range of V migration, low vacancy concentration
 - Self-limiting (2)
- Hydrogen breaking away from NV
 - NVH stable up to 1600C (1)
- NV0 turning into NV-
 - Via high energy photons (4)
- Presence of some other defect (Nickel, Boron, etc.)



Issues

- Red laser optimization
- Image stitching/overlaying
- Nonuniform NV- distribution



NV density vs y at 100 um depth

